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Docket No.: 2336-254

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Sun Woon KIM

Confirmation No.2939

U.S. Patent Application No. 10/806,432

Group Art Unit: 2812

Filed: March 23, 2004

Examiner: RICHARD A. BOOTH

For: FABRICATION METHOD OF NITRIDE SEMICONDUCTORS AND NITRIDE SEMICONDUCTOR STRUCTURE FABRICATED THEREBY

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

By Official Action mailed August 15, 2005 restriction to one of the following inventions is required under 35 USC 121:

In response, Applicants hereby elect Species 1 (Fig. 1), claims 1-6 being readable thereon for examination in this case.

A divisional application will be filed for the non-elected claims.

CERTIFICATION OF FACSIMILE TRANSMISSION  
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE

ON THE DATE SHOWN BELOW

Tiara L. Hell  
TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION  
Tiara L. Hell 9/13/05  
SIGNATURE DATE  
571-273-8300  
FACSIMILE NUMBER